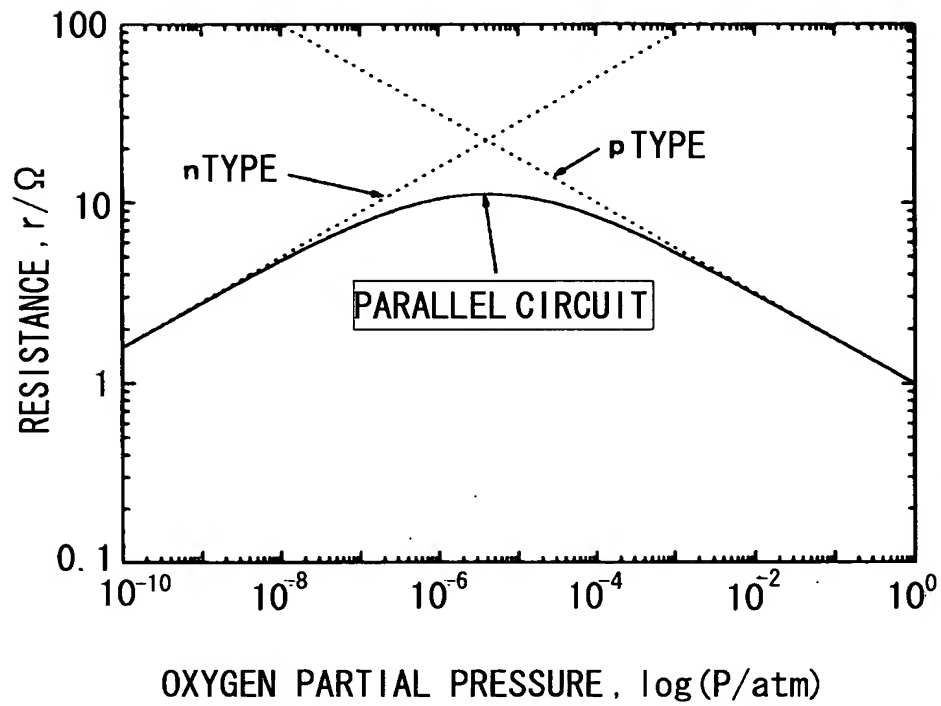
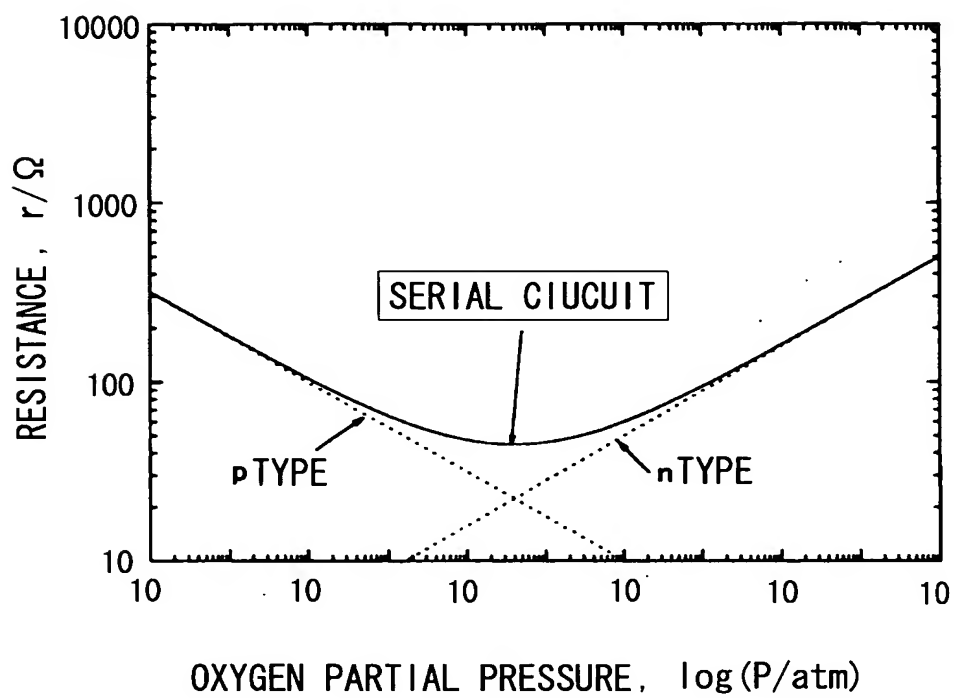


1 / 1 2



F i g . 1

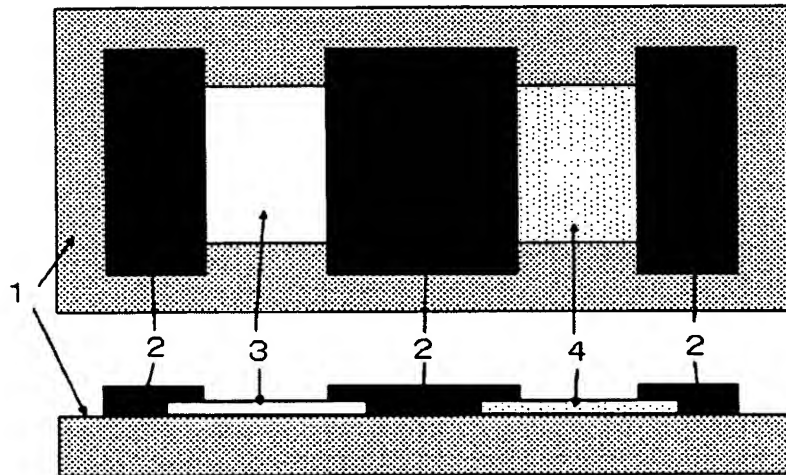
2 / 12



F i g . 2

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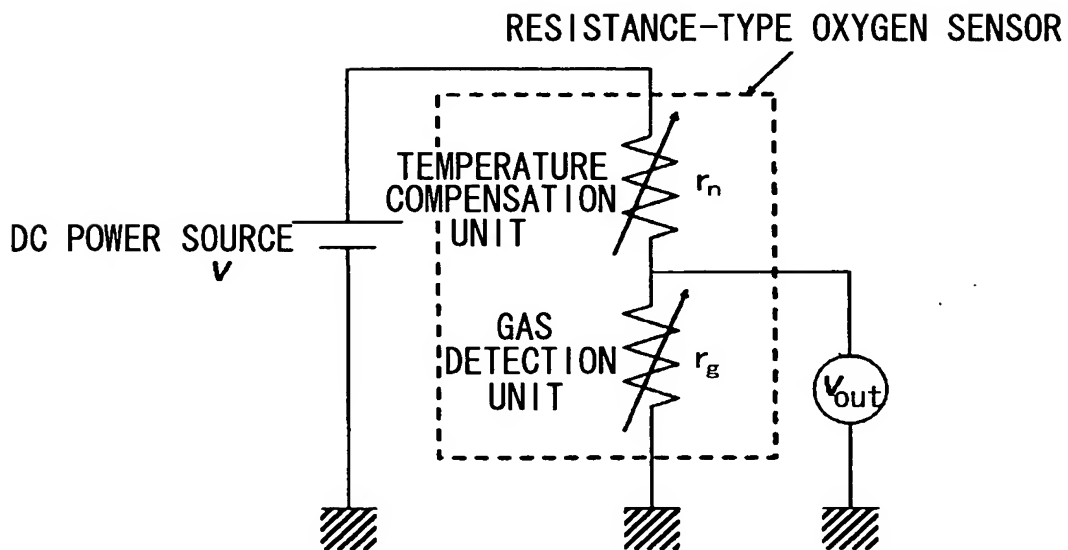
3 / 1 2



- 1 ... SUBSTRATE
- 2 ... ELECTRODE
- 3 ... GAS DETECTION UNIT (OXIDE SEMICONDUCTOR)
- 4 ... TEMPERATURE COMPENSATION UNIT
(OXYGEN ION CONDUCTOR)

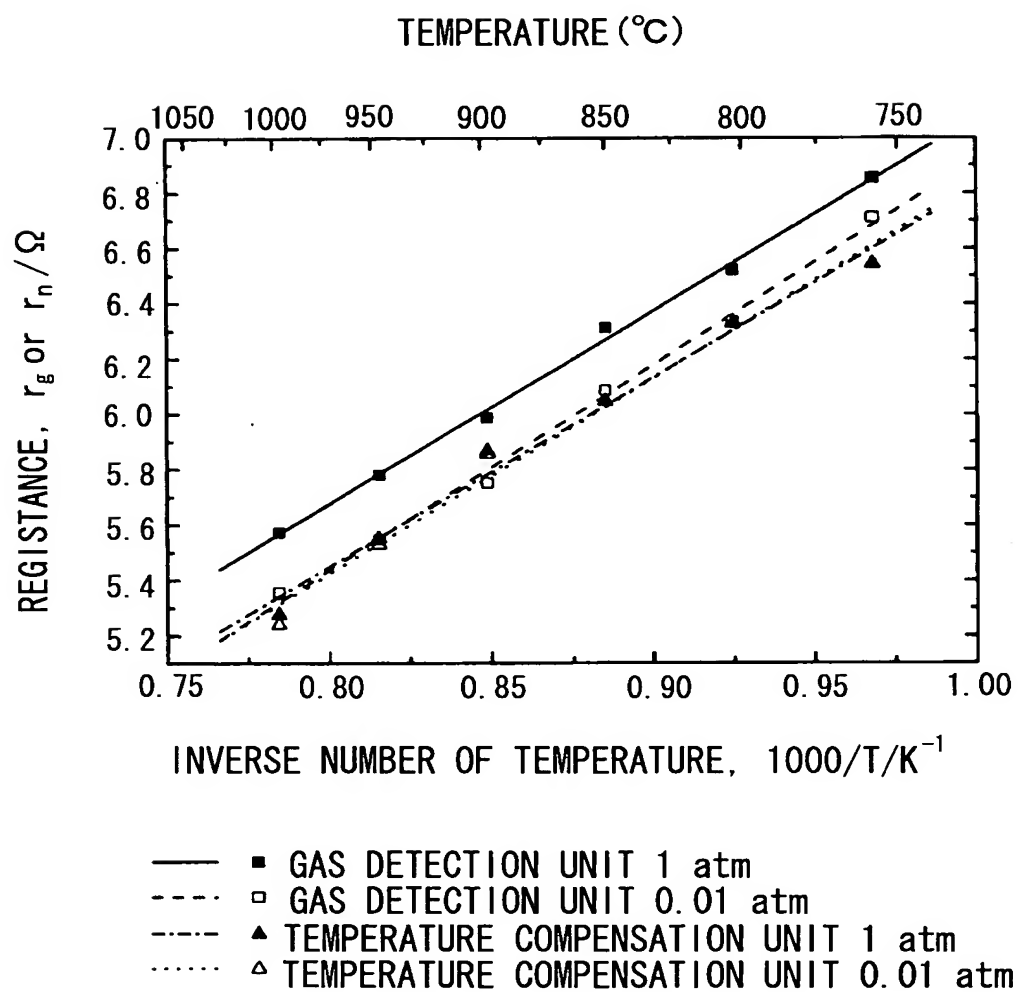
F i g . 3

4 / 1 2



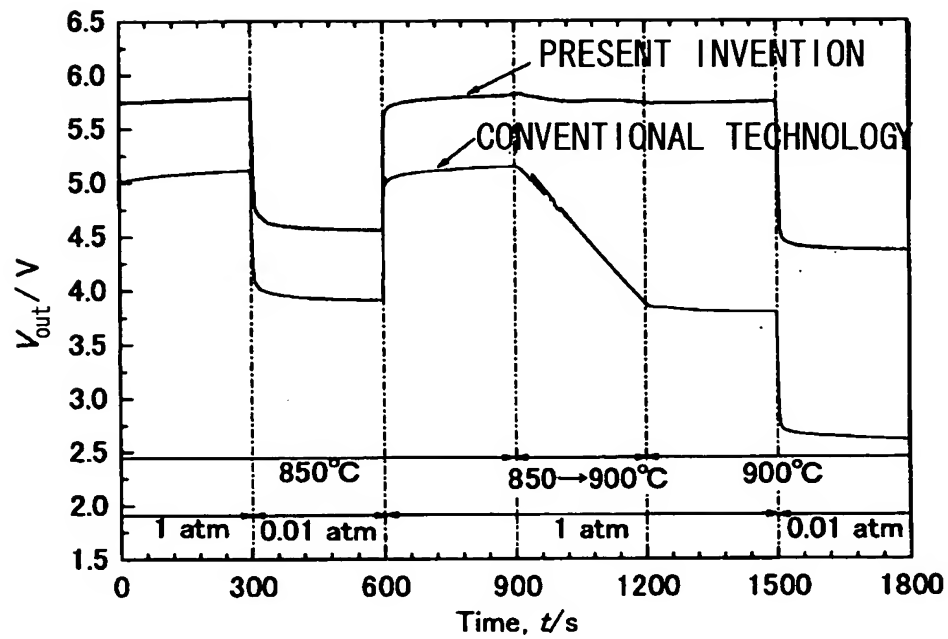
F i g . 4

5 / 1 2



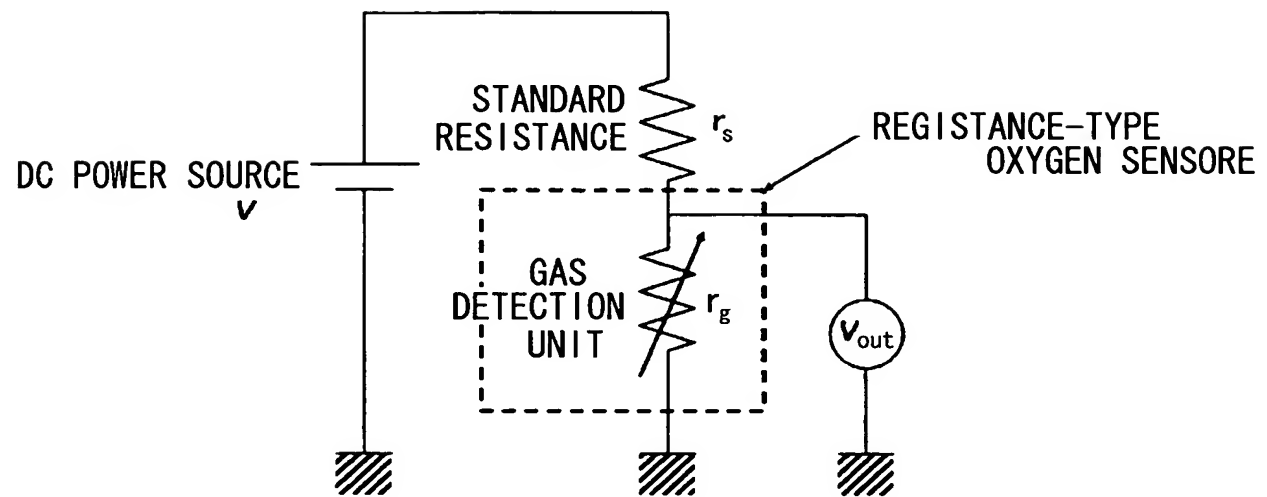
F i g . 5

6 / 1 2



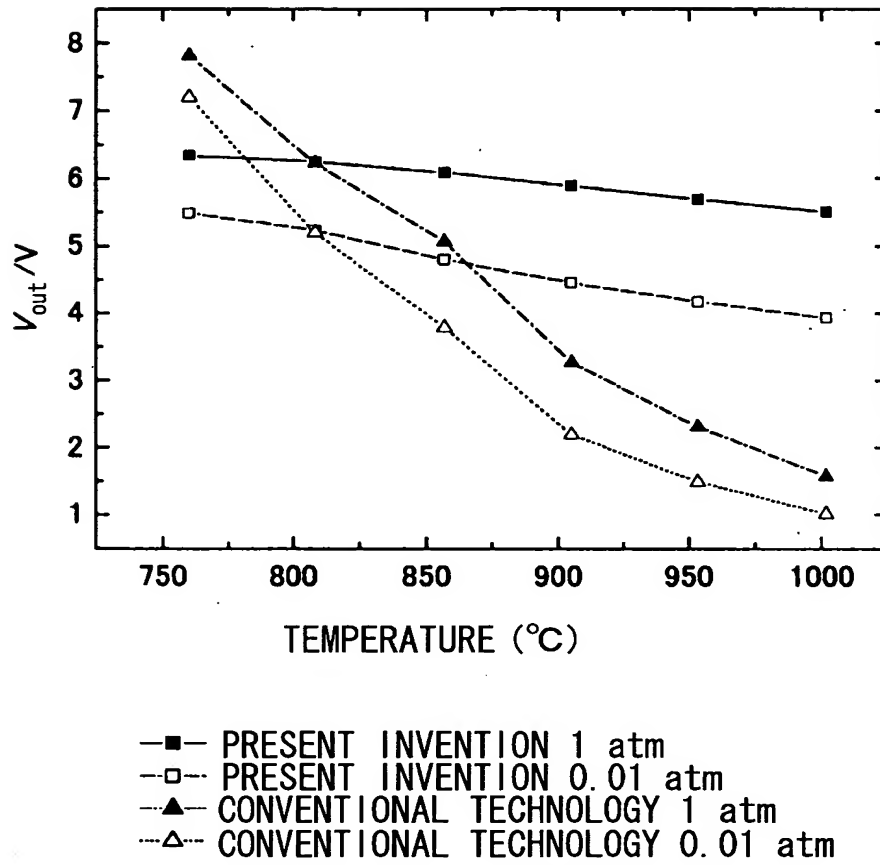
F i g . 6

7 / 1 2



F i g . 7

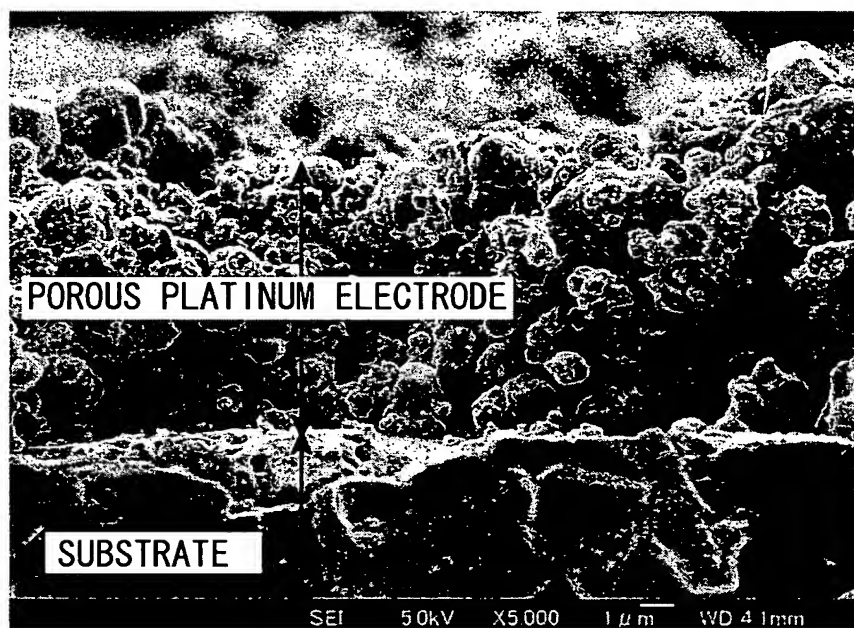
8 / 1 2



F i g . 8

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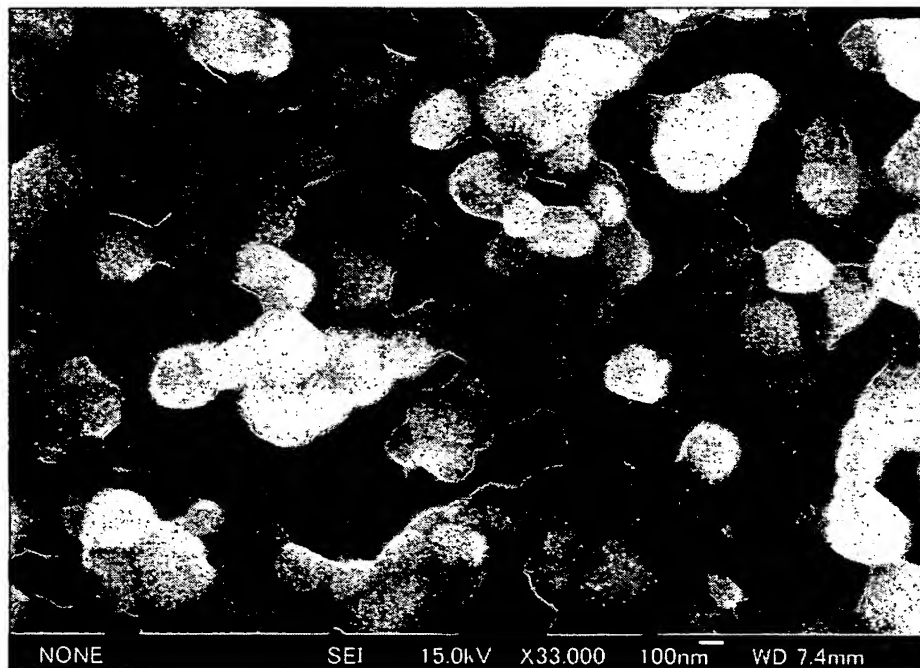
9 / 1 2



F i g . 9

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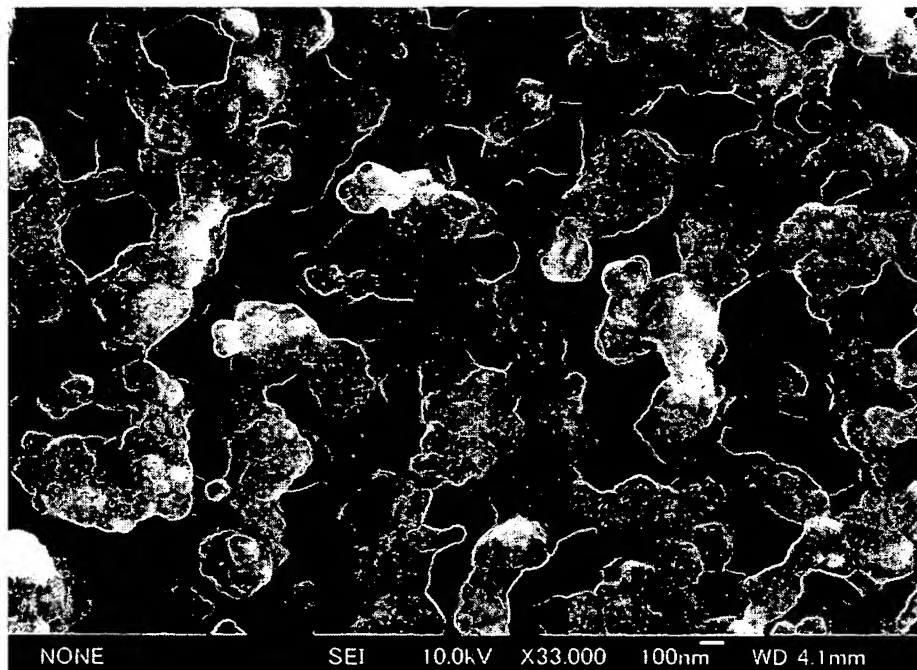
10 / 12



F i g . 1 0

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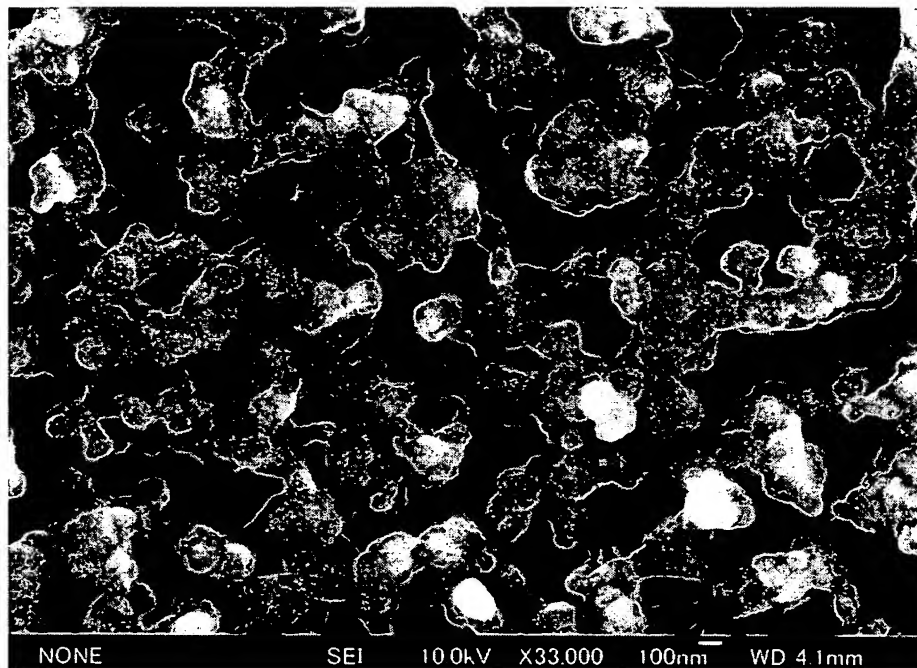
11 / 12



F i g . 1 1

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F i g . 1 2